

Notice of References Cited	Application/Control No. 10/600,050	Applicant(s)/Patent Under Reexamination MANKOS ET AL.	
	Examiner Zia R. Hashmi	Art Unit 2881	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-6,566,897	05-2003	Lo et al.	324/751
	B	US-6,710,342	03-2004	Jau et al.	250/311
	C	US-			
	D	US-			
	E	US-			
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Suzuki et al., "Workpiece Holder, Semiconductor Fabricating Apparatus, Semiconductor Inspection Apparatus....", Pub. No: US 2003/0155508 A1, pub. date: August 21, 2003.
	V	
	W	
	X	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
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